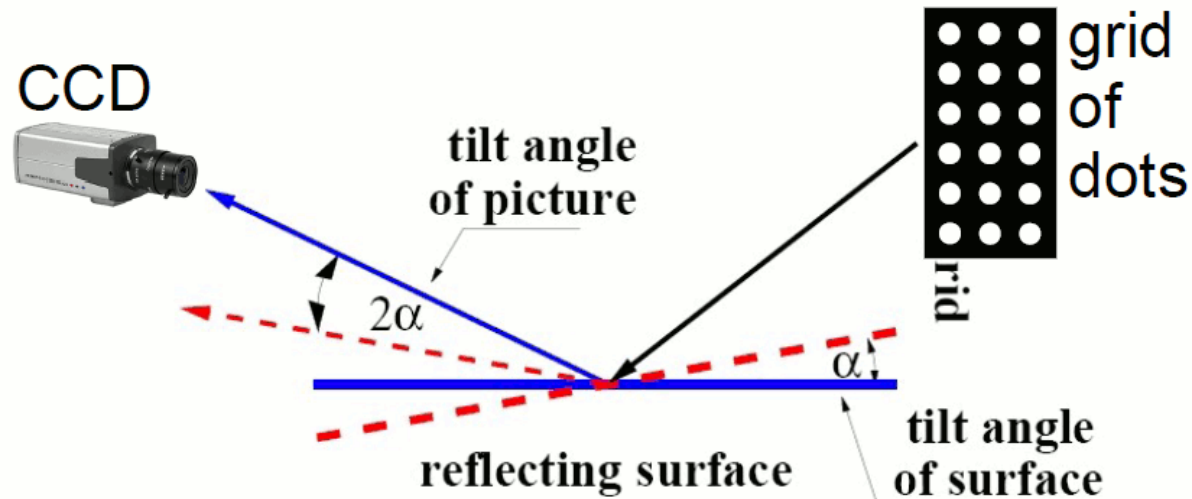


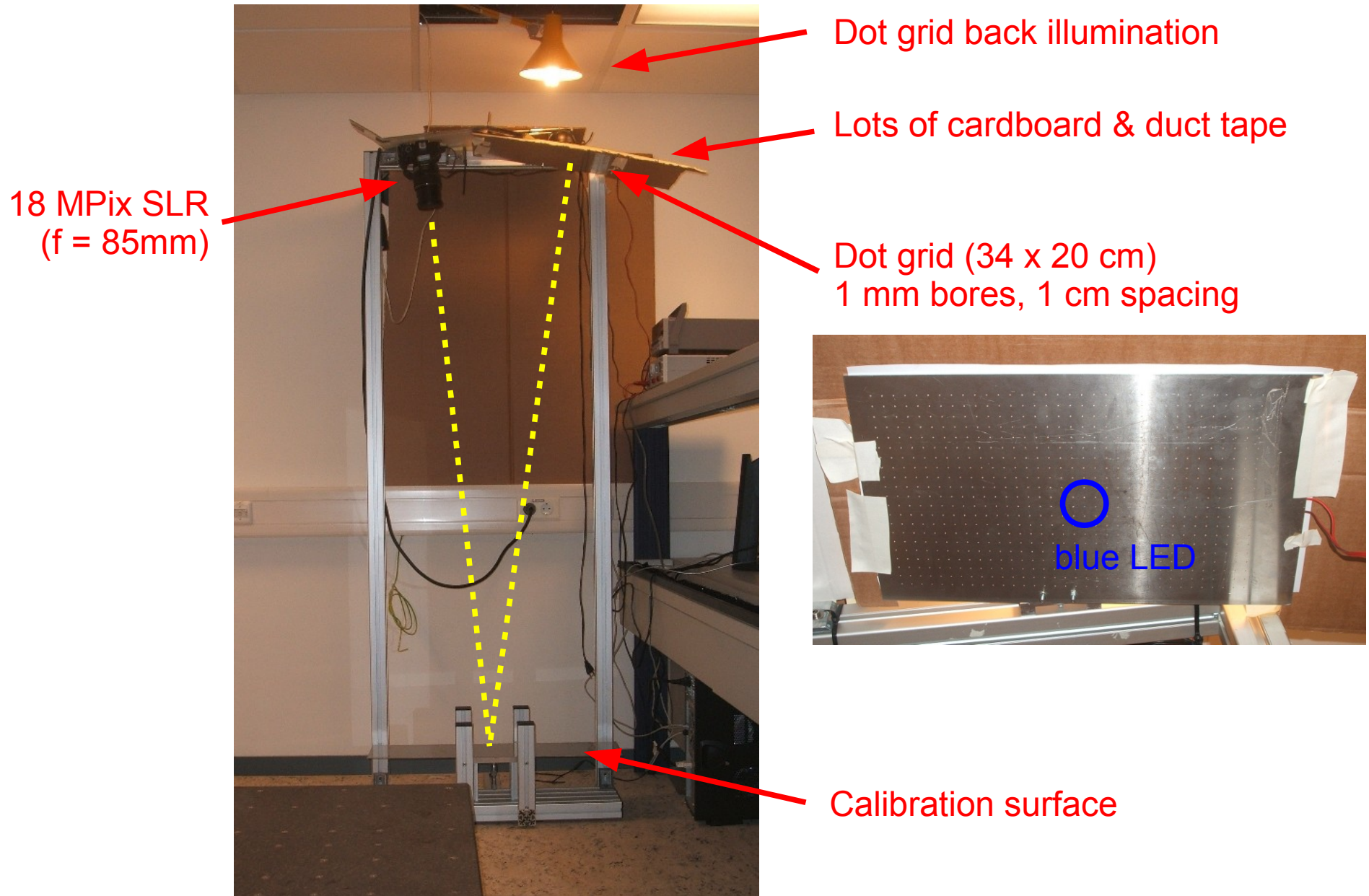
# Status of the deformation measurement setup & software

# Basic principle

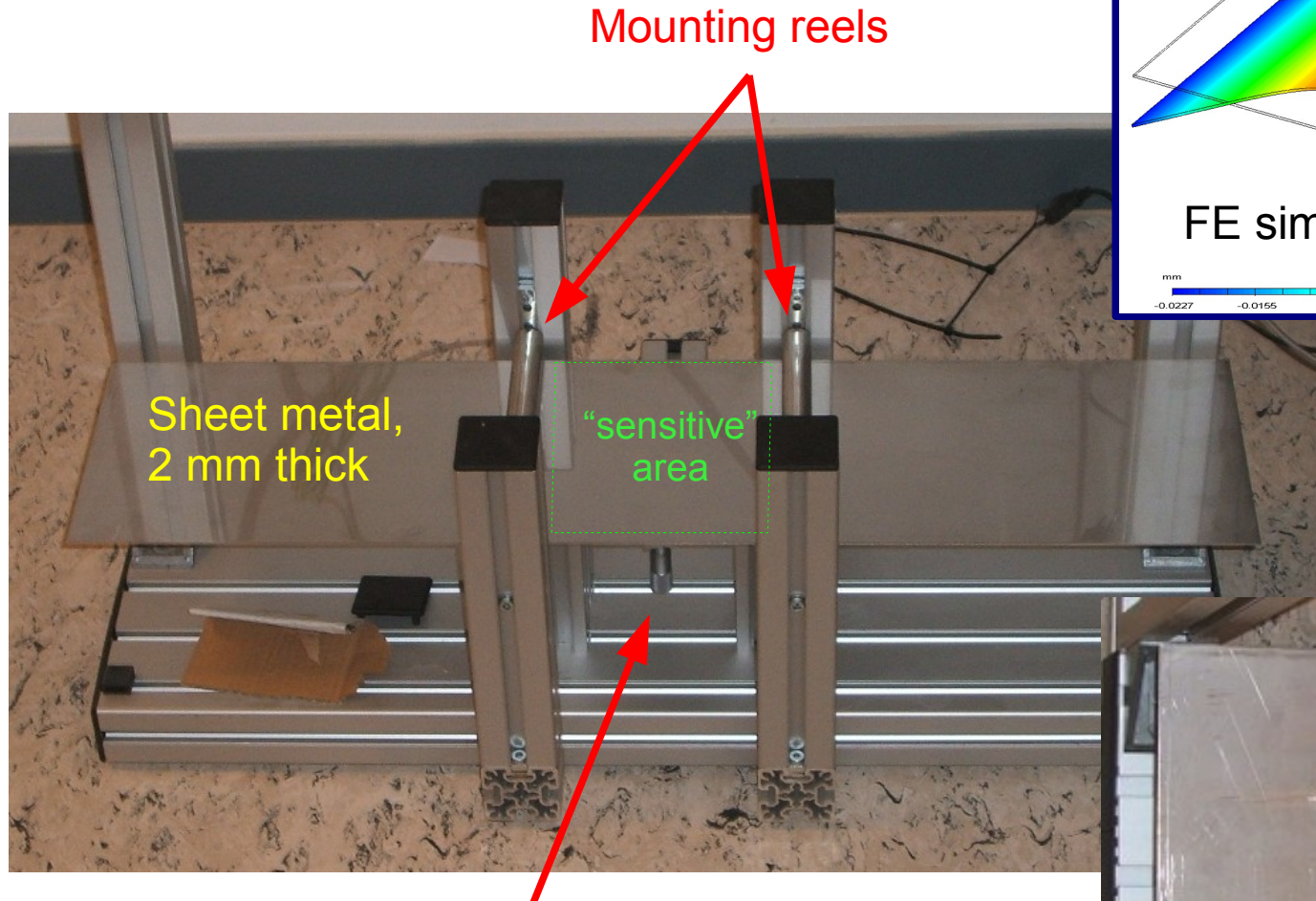
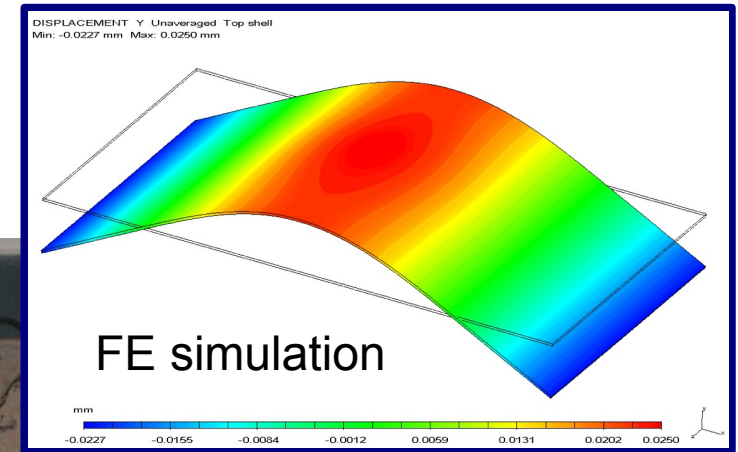


- surface under test reflects a grid of dots or LEDs, observed by a CCD
- tilt of surface elements (deformations) lead to a displacement of the dots on the CCD
- full 3D “sampled” surface reconstruction possible –
  - **relative to a reference shape/image** (typically at room temperature)
  - **accuracy ~10  $\mu\text{m}$**  can be reached
  - only “intrinsic” deformation – global offsets or tilts cannot be reconstructed

# Teststand mock-up



# Calibration surface



Micrometer screw pointing upwards,  
25/250  $\mu\text{m}$  pitch (fine/coarse)

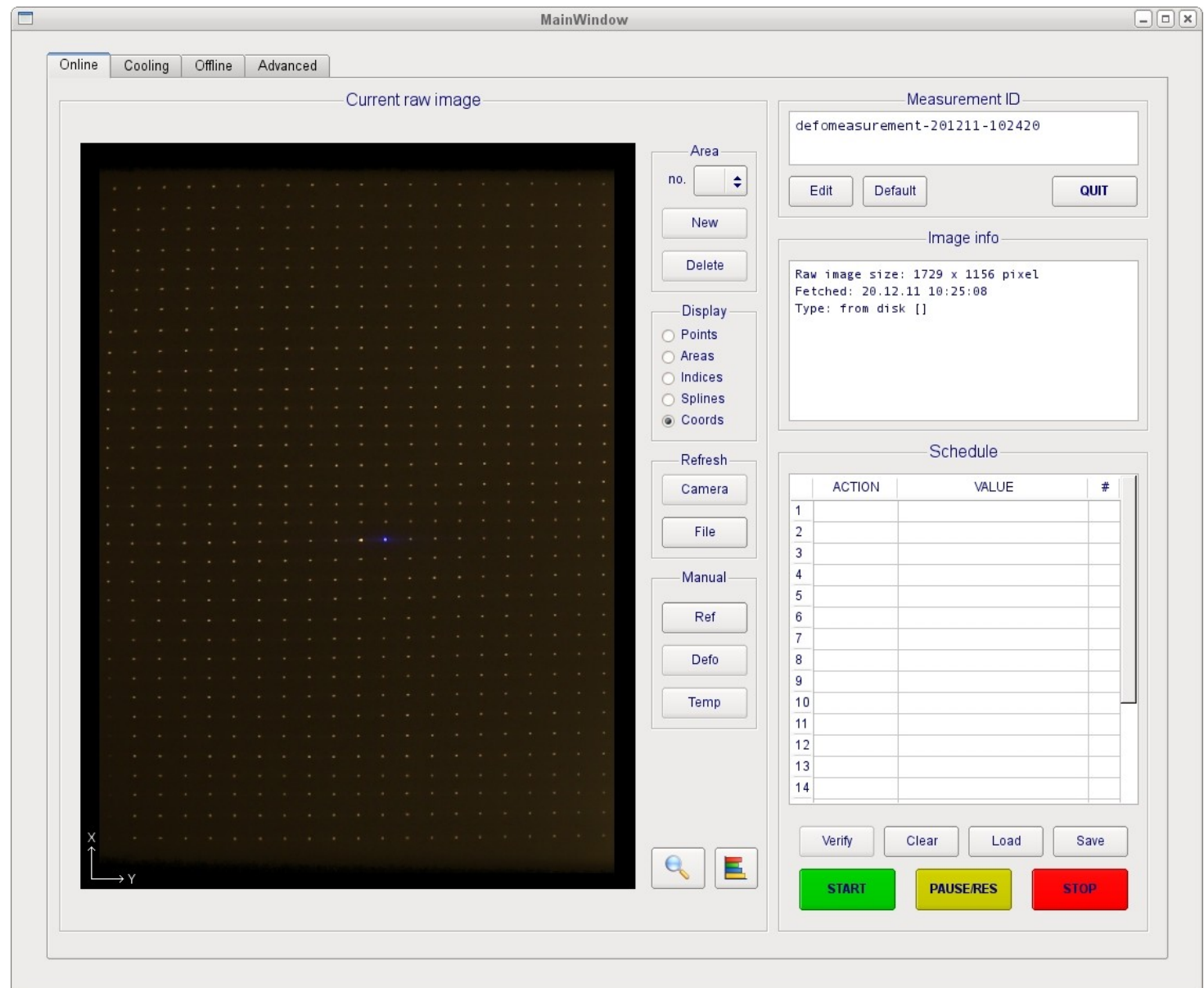




# Reconstruction: reference image

## Reference image:

- micrometer screw gently touches sheet (slight bias)
- for thermal defo measurements, reference would typically be at room temperature

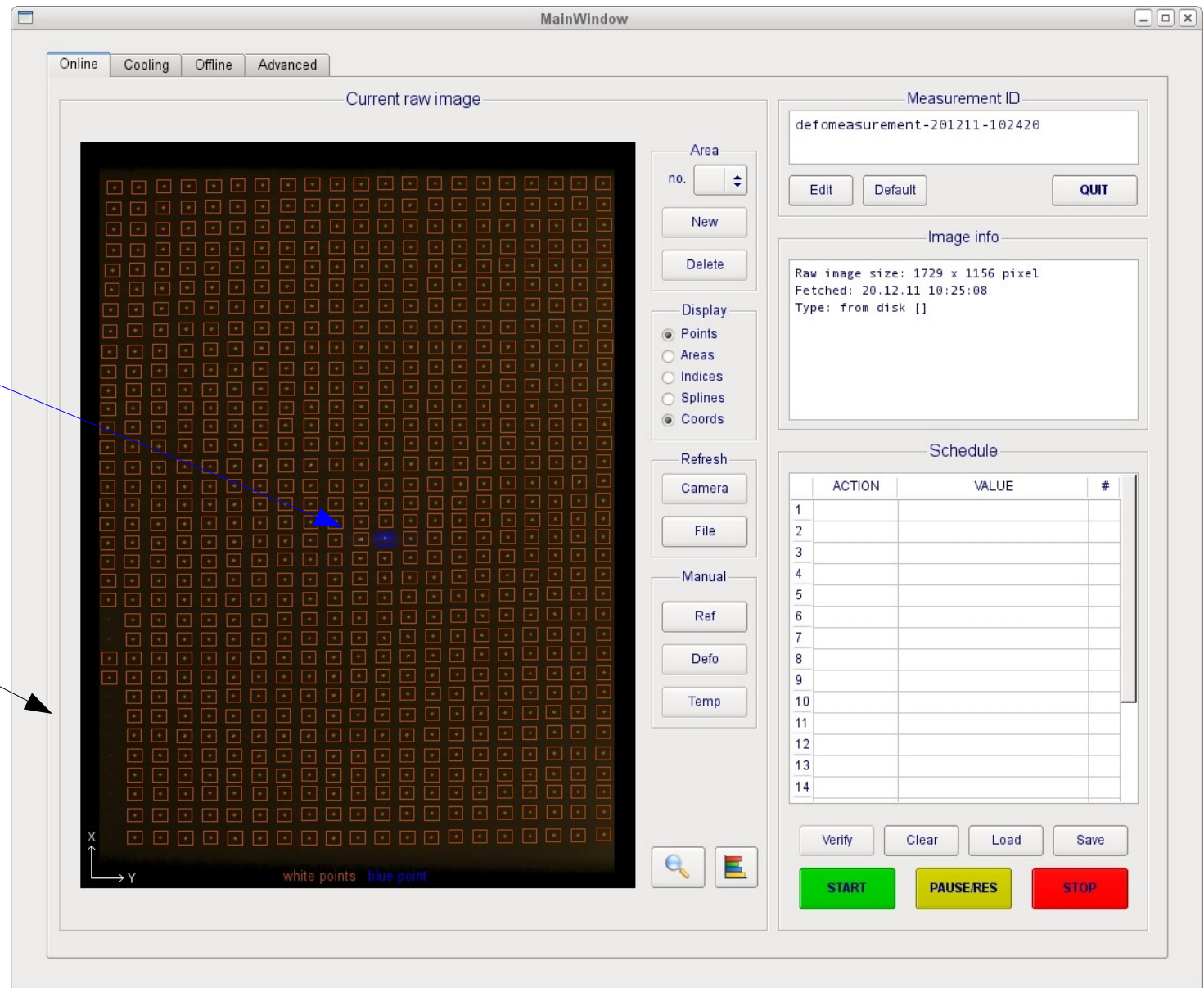


# Reconstruction: reference image

point reconstruction  
successful

blue point as  
coordinate reference

some points  
not found  
(too low contrast)

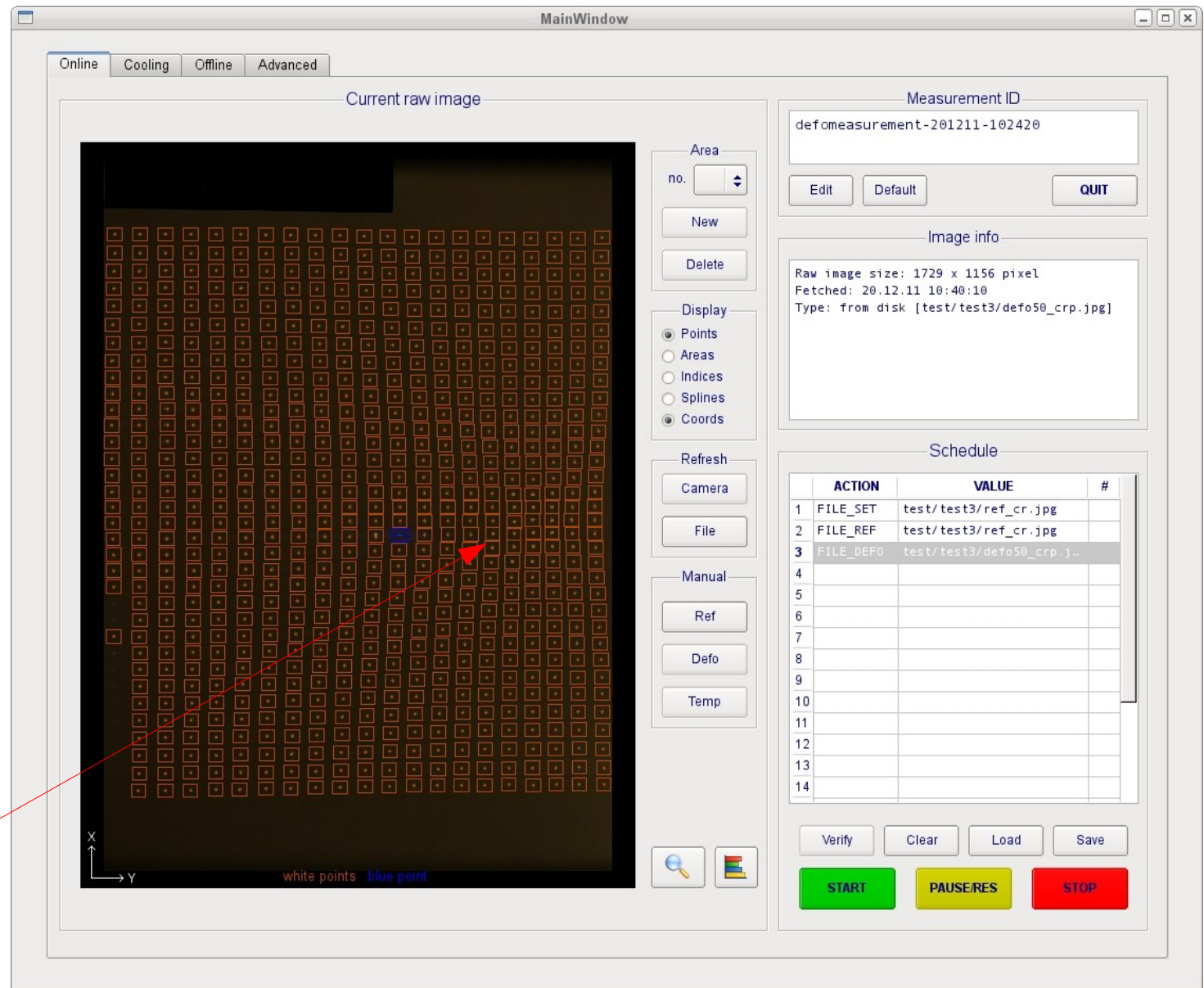


# Reconstruction: deformation image

## Deformation image:

- micrometer screw **500  $\mu\text{m}$**  upwards
- some postprocessing necessary due to very low contrast and bad ambient light conditions (few points manually enhanced)

“bump” from the pressure point

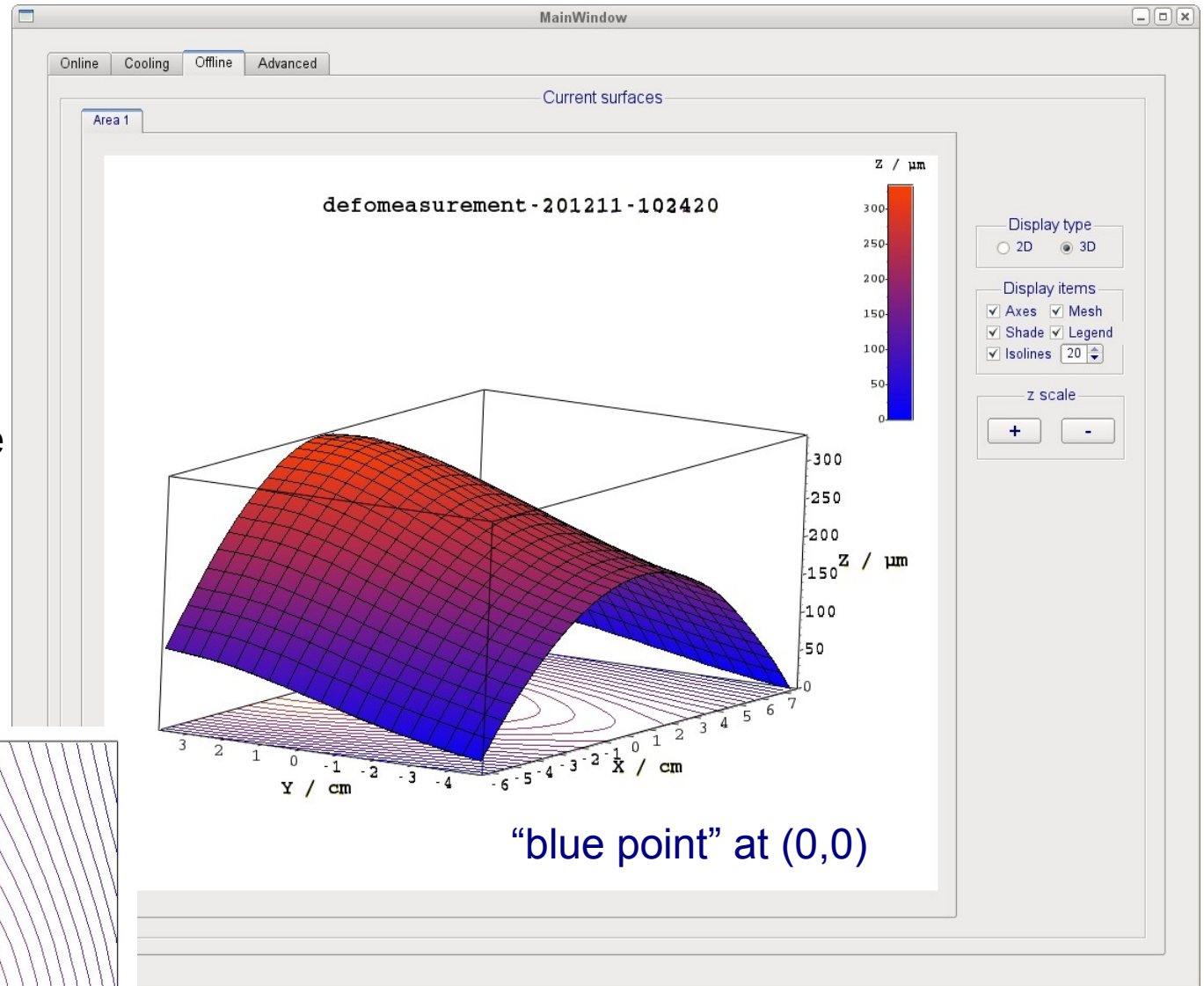
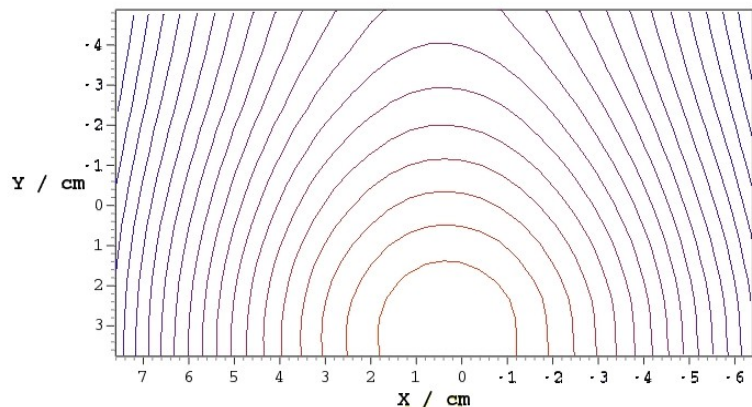




# Reconstruction: surface

**Result yields ~320  $\mu\text{m}$  deformation amplitude**

- reconstruction parameters (setup geometry) not yet properly adjusted
- metal sheet too stiff and not uniform (kinks)
- postprocessing might have introduced a bias (“bump” might be more protruding)
- parts of the surface obstructed by reels



→ **systematic measurements at various amplitudes**



# Software developments

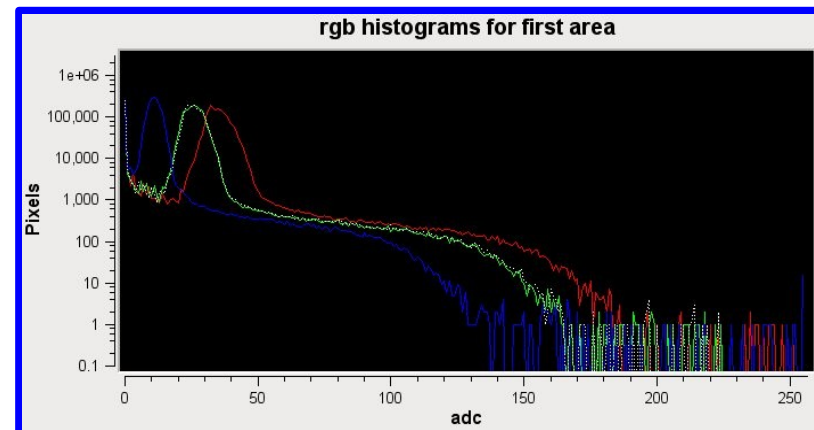
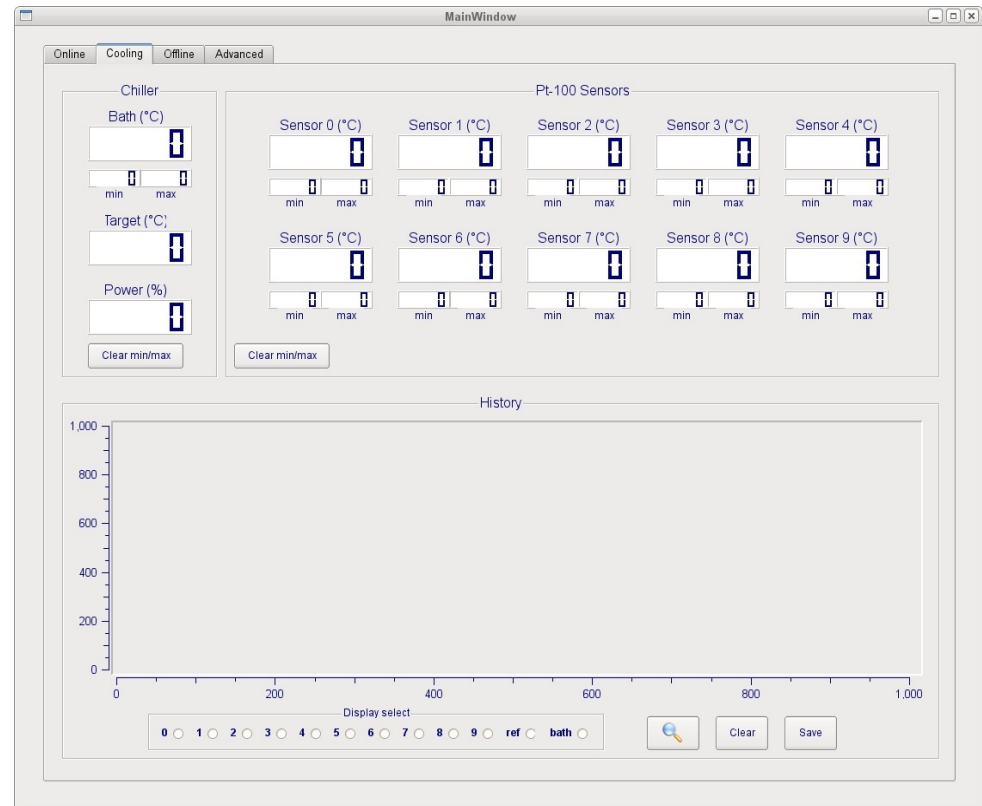
## Already functional:

- remote operation of camera
- image analysis (histograms, etc.)
- file & reconstruction results output
- restrict reconstruction to areas
- programmable schedule (automatic measurement series, temperature cycles, etc.)
- ...

## Upcoming:

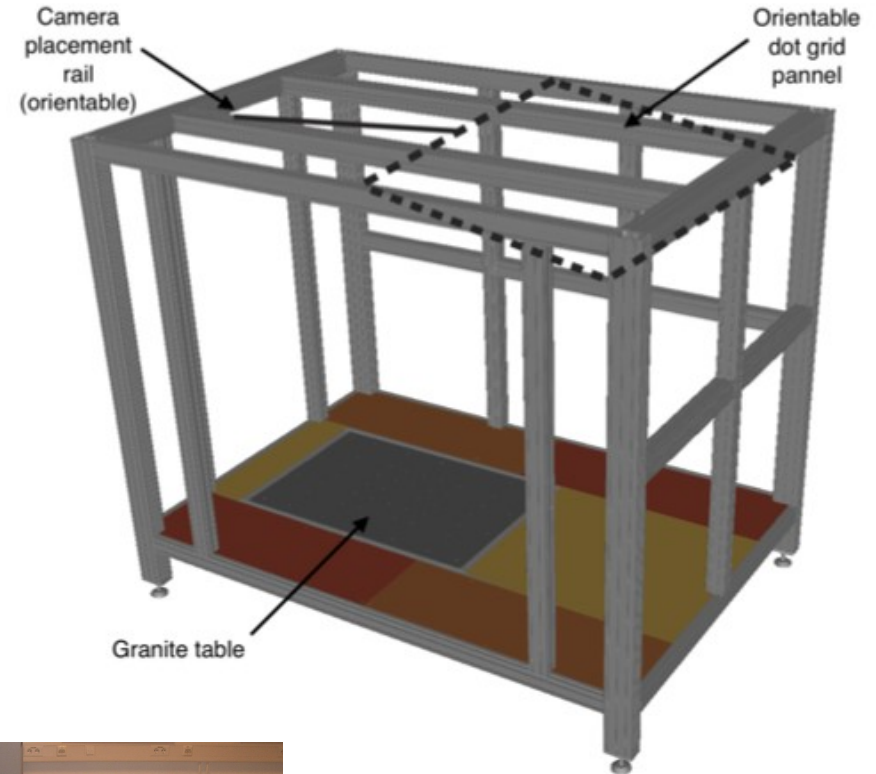
- chiller remote control
- temperature probes
- standalone result “viewer”
- camera whitebalance
- multiple simultaneous areas processing
- whatever else is needed ...

} partly  
done



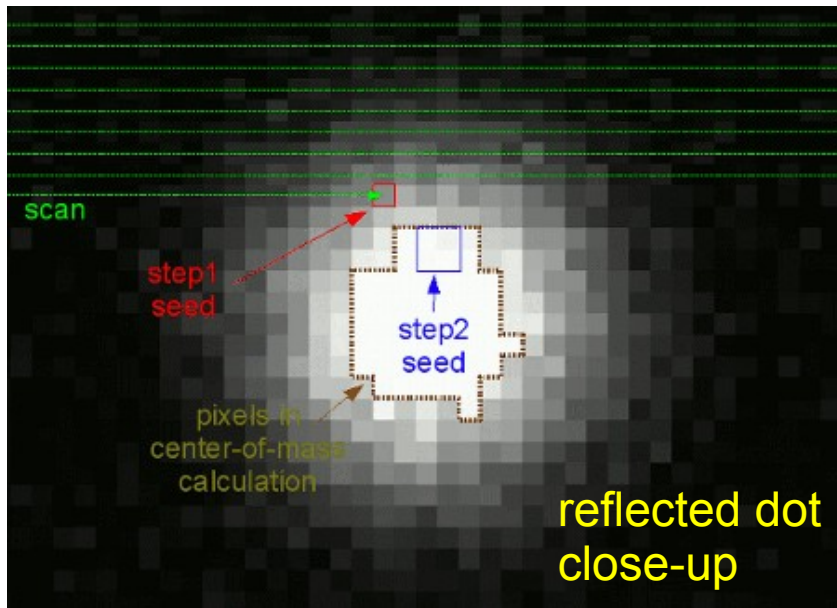
# Final setup

- for large scale application up to  $\sim 80 \times 80$  cm (ATLAS petals)
- dark environment, low ambient light through LED backlight illumination
- some scaffolding parts already delivered
- need to duplicate temperature probe readout
- time scale  $\sim 2$  months

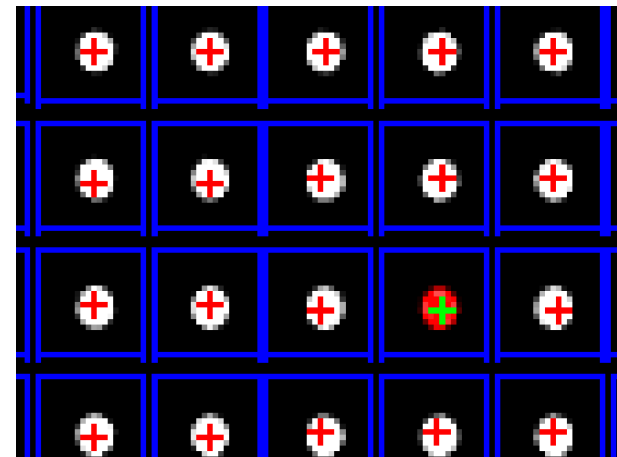
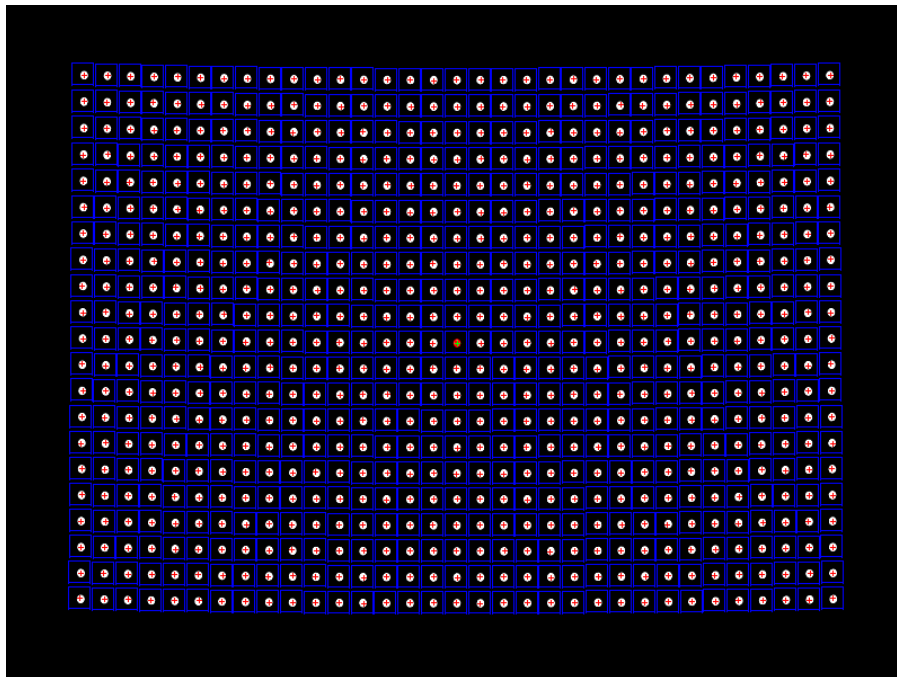


more slides

# surface reconstruction: point finding



- scan along x,y row-wise and compute grayscale ADC values
- stop at pixel > threshold **T1** (step1 seed)
  - evaluate group of pixels in vicinity
  - if average > threshold **T2** (step2 seed)
    - accept point
    - determine point position by center-of gravity of all pixels around seed2 with grayscale ADC > threshold **T3**
  - average red/cyan ratio of pixels to determine if the point is “red”





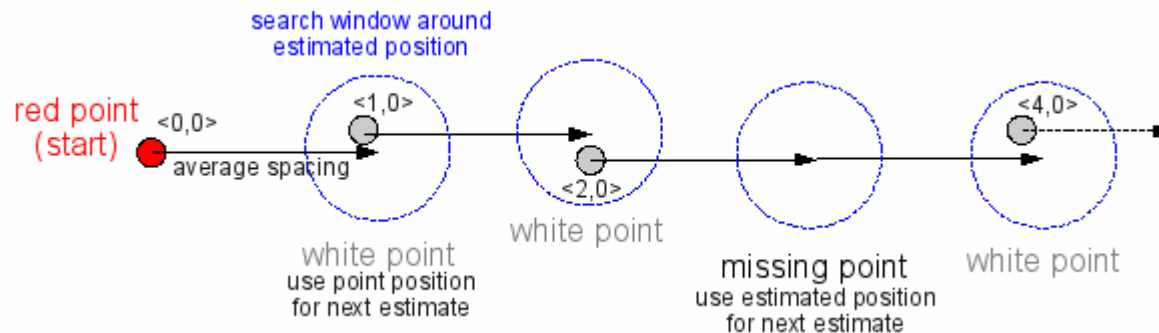
# surface reconstruction: point indexing

Must consider that points might be missing:

- gaps in multi-component surfaces
- points not properly reflected (diffraction, surface quality, ... )

Indexing assigns position indices (0..N, 0..M) to the reconstructed points:

- 1:1 matching of reflected points to the grid
- red point in the middle is used as reference (0,0)
- average spacing along x and y is determined to estimate the positions of the next point(s)



Indices are used to match points in reference and “current” image

Requires proper tuning of reconstruction & setup parameters (size of search window, distance of dots in grid, etc.)

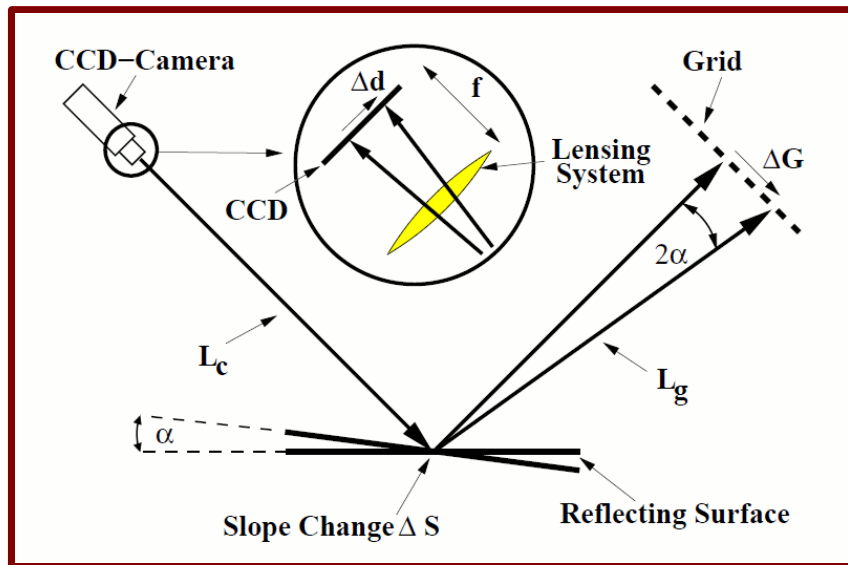
# surface reconstruction: calculating the surface slope

Parameters for determining the surface slope:

- focal length of camera lens  $f$
  - CCD pixel pitch  $P$
  - distance camera-sensor  $L_c$
  - distance sensor-grid  $L_g$
- } depend on viewing angle

Point shift on sensor  $\Delta d$   
(between current & reference image)  
is measured

$$\tan [2 \cdot \arctan (\Delta S)] \cdot L_g (\delta) = \frac{\Delta d \cdot P}{f} \cdot [L_g (\delta) + L_c (\delta)]$$



Gives the surface slope changes  $\Delta S$   
between reference and current state  
at the position of a point  
→ spatial integration required

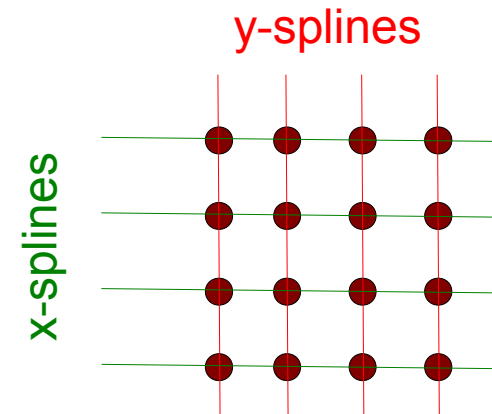
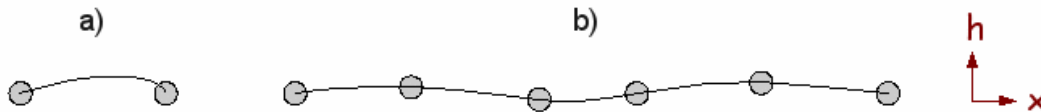
Viewing angle corrections to  $L_c$  and  $L_g$   
currently not applied (need to calculate)

# surface reconstruction: spline fitting

Indexed points are grouped in “rows” (along x) and “columns” (along y)  
→ fit a quadratic spline to each group

$$h(x) = A \cdot x^2 + B \cdot x + C$$

$h$  := surface height (deformation amplitude)



For all splines along a “row” or “column” :

$$h_j(x_{j+1}) = h_{j+1}(x_{j+1}) \text{ for } j = 1..N-1 \quad \text{continuity at the intersections}$$

$$\frac{\delta h_j}{\delta x}(x_{j+1}) = \frac{\delta h_{j+1}}{\delta x}(x_{j+1}) = h_{j+1} \text{ for } j = 1..N-1 \quad \text{continuity of 1}^{\text{st}} \text{ derivative}$$

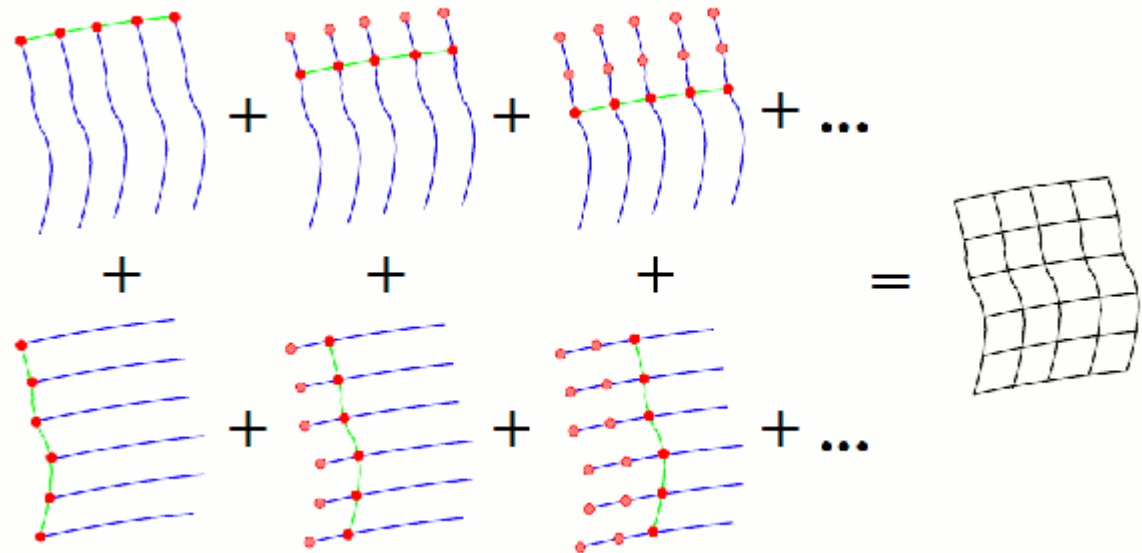
$$\frac{\delta h_1}{\delta x}(x_1) = s_1, h_1 = 0 \quad \begin{array}{l} \text{freedom of choice for global height (parameter C)} \\ \text{which cannot be reconstructed} \\ \text{since we have changes in slope } \Delta S \text{ only} \end{array}$$

→ equation system can be solved to obtain surface profile along spline

# surface reconstruction: spline cross-mounting

Splines are “cross-mounted” on each other:

- take 1<sup>st</sup> spline along x and adjust the height of all perpendicular y-splines at the shared point (“mount” them on the x-spline)
- take 2<sup>nd</sup> spline along x ...
- ...
- repeat procedure in perpendicular direction

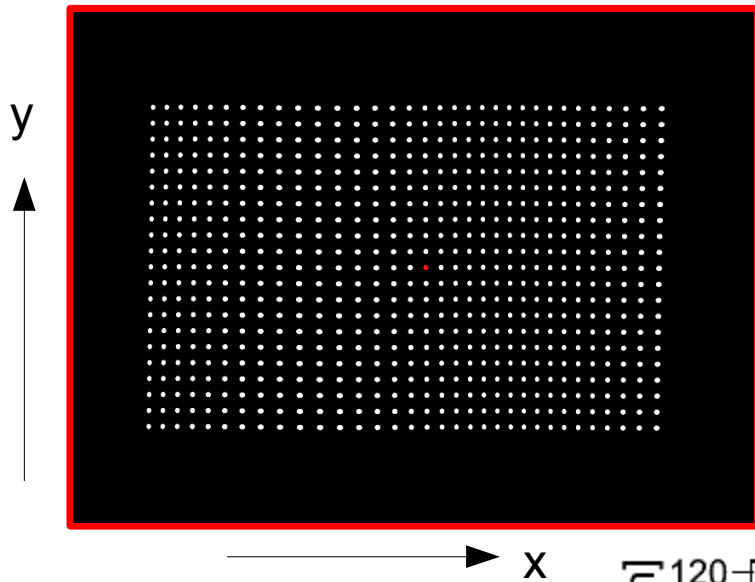


The average of all adjustments determines the global height of a spline  
→ smooth surface

Finally, correct for global surface height offset (lowest point set to 0)  
and tilt (rotate surface such that average normal is perpendicular to x-y-plane, TODO)



## simulation examples: a sine "wave" along y



Simulated surface:  
 $z = 50 \mu\text{m} * \sin(6 / \text{cm} * x)$

